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Bib Data Sheet

CONFIRMATION NO. 8882

SERIAL NUMBER 10/800,377	FILING DATE 03/11/2004  RULE	CLASS 438	GROUP ART UNIT 2822	ATTORNEY DOCKET NO. NOVLP089/NVLS-002886/0028
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CIP of 10/672,311 09/26/2003

*W*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*W none*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/28/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>W</i>	OR	5	53	3

## ADDRESS

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## TITLE:

Method and apparatus for UV exposure of low dielectric constant materials for porogen removal and improved mechanical properties

FILING FEE

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1382

FEES: Authority has been given in Paper

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